



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/902,277
Filing DateJuly 9, 2001
Inventor.....Gurtej S. Sandhu et al.
Assignee.....Micron Technology, Inc.
Group Art Unit.....2813
Examiner Schillinger, Laura M.
Attorney's Docket No.MI22-1780
Title: Method of Forming a Thin Film Transistor

RESPONSE TO OCTOBER 21, 2003 FINAL ACTION ACCOMPANYING RCE FILING

To: Mail Stop RCE
Commissioner for Patents
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AMENDMENTS

Introductory Comments

In reply to the Final Office Action of October 21, 2003, applicant amends and remarks as follows.

